EXPEDITED PROCEDURE PURSUANT TO 37 C.F.R. § 1.116 ART UNIT 2815

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TECHNOLOGY CENTER 2800

To:

Examiner Edgardo Ortiz

Phone No.

(703) 308-6183

Technology Center:

2815

Total Pages Sent (including cover sheet): 8

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Transmission Date: February 3, 2003

Applicants:

Jingyu Lian, et al.

Docket No.:

00 P 9119 US

Scrial No:

09/751,551

Date Filed:

December 28, 2000

Title:

MULTI-LAYER Pt ELECTRODE FOR DRAM AND FRAM

WITH HIGH K DIELECTRIC MATERIALS

CERTIFICATION OF FACSIMILE TRANSMISSION PURSUANT TO 37 C.F.R. § 1.8(a)(1)(i)(B)

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at (703) 308-7722 on the date shown above:

Amendment Pursuant to 37 C.F.R. § 1.116 (7 pages).

Respectfally submitted,

Reg. No. 38,495

Confirmation Respectfully Requested

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Lacok

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Jingyu Lian, et of. 09/751,551

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Ortiz, Edgardo

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Commissioner for Patents Washington, D.C. 20231

FEB 0 3 2003

TECHNOLOGY CENTER 2800

Amendment Pursuant to 37 C.F.R. § 1.116

Dear Sir:

The following remarks are presented in response to the Examiner's Final Office Action mailed on December 2, 2002. They are respectfully submitted as a full and complete response to that Office Action. Entry of the present amendment and favorable consideration of the abovereferenced patent application are respectfully requested.

Please amend the above-referenced application as described below.

In the Claims:

Please amend Claim 29 as follows:

29. (Amended) The multi-layer electrode according to Claim 28 wherein the conductive oxide comprises IrO2 or RuO2.

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